

ELECTRONIC INFORMATION DISCLOSURE STATEMENT

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Title of Invention	LADDER-TYPE GATE STRUCTURE FOR FOUR-TERMINAL SOI SEMICONDUCTOR DEVICE
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Application Number :

Confirmation Number:

First Named Applicant: Paul Hyde

Attorney Docket Number: BUR920030094US1

Art Unit:

Examiner:

Search string: (6436744 or 6249477 or 6307237 or 6275059 or 5930605 or 5770881 or 5215931 or 4983535 or 20030064567 or 20020106844 or 20020053706).pn

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
	1	6436744	2002-08-20	Bryant et al.			
	2	6249477	2002-08-06	Mandelman et al.			
	3	6307237	2001-10-23	Erstad			
	4	6275059	2001-08-14	Sah et al.			
	5	5930605	1999-07-27	Mistry et al.			
	6	5770881	1998-06-23	Pelella et al.			
	7	5215931	1993-06-01	Houston			
	8	4983535	1991-01-08	Blanchard			

US Published Applications

Note: Applicant is not required to submit a paper copy of cited US Published Applications

init	Cite.No.	Pub. No.	Date	Applicant	Kind	Class	Subclass
	1	20030064567	2003-04-03	Chaudhry et al.			
	2	20020106844	2002-08-08	Kotani			
	3	20020053706	2002-05-09	Jung et al.			

Signature

Examiner Name	Date
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